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P/1596-76

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Takashi IZUTA

Date: July 13, 2004

Serial No.: 10/806,885

Group Art Unit: 3749

Filed: March 22, 2004

Examiner: ---

For: SUBSTRATE TREATING METHOD AND APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on July 13 2004

Respectfully submitted,

James A. Finder

Name of applicant, assignee or
Registered Representative

Signature

July 13, 2004

Date of Signature

James A. Finder

Registration No.: 30,173

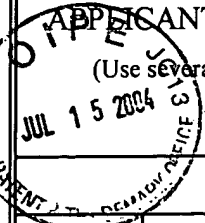
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Enclosures

 <p>APPLICANT'S ART CITATION (Use several sheets if necessary)</p>		Application 10/806,885		OFGS File No. P/1596-76			
		Applicant Takashi IZUTA					
		Filing Date March 22, 2004		Group Art Unit 3749			
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	08-067413	03-1996	Japan			x	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
Examiner		Date Considered					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							